

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

January 23, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG762566894

Report verification at igi.org

PROPORTIONS

Slightly Thick

11.5%

50.5%

71%

Long

66.5%

Sample Image Used

IGI LG762566894

CLARITY CHARACTERISTICS

KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

LABORATORY GROWN DIAMOND REPORT

January 23, 2026

IGI Report No LG762566894

EMERALD CUT

9.83 X 6.95 X 4.62 MM

3.02 CARATS

F

SI 1

EXCELLENT

EXCELLENT

NONE

IGI LG762566894

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LABORATORY GROWN DIAMOND REPORT

January 23, 2026

IGI Report No LG762566894

EMERALD CUT

9.83 X 6.95 X 4.62 MM

3.02 CARATS

F

SI 1

EXCELLENT

EXCELLENT

NONE

IGI LG762566894

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

IGI

© IGI 2020, International Gemological Institute

FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

January 23, 2026

IGI Report No LG762566894

EMERALD CUT

9.83 X 6.95 X 4.62 MM

3.02 CARATS

F

SI 1

EXCELLENT

EXCELLENT

NONE

IGI LG762566894

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa